

Applicants:	Bipin S. Parekh, Jeffrey J. Spiegelman, Robert S. Zeller and Russell J. Holmes		
Application No.:	10/565,486	Group:	1797
Filed:	May 4, 2006	Examiner:	Jason M. Greene
Confirmation No:	2074		
For:	LITHOGRAPHIC PROJECTION APPARATUS, PURGE GAS SUPPLY SYSTEM AND GAS PURGING METHOD		

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This Amendment is being filed in response to the Office Action mailed from the U.S. Patent and Trademark Office on March 3, 2010 in the above-identified application, and accompanies the filing of a Request for Continued Examination. Reconsideration and further examination are requested.

Please amend the application as follows: